

PATENT  
Atty Docket No.: 10005208-1 RECEIVED  
CENTRAL FAX CENTER

**In The U.S. Patent and Trademark Office****JUN 19 2006****In Re the Application of:**

**Inventor(s):** Osamu Samuel NAKAGAWA      **Confirmation No.:** 3642  
**Serial No.:** 09/891,325      **Examiner:** Chuong A. Luu  
**Filed:** June 27, 2001      **Group Art Unit:** 2818  
**Title:** HIGH-DIELECTRIC CONSTANT METAL-INSULATOR METAL  
CAPACITOR IN VLSI MULTI-LEVEL METALLIZATION SYSTEMS

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF FACSIMILE TO THE USPTO**

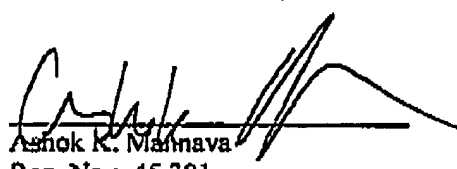
I hereby certify that this correspondence is being transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on June 19, 2006. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment (2 copies).  
9 sheets of Amendment Under 37 C.F.R. § 1.111.

Respectfully submitted,

MANNAVA & KANG, P.C.

June 19, 2006

  
Ashok K. Mannava  
Reg. No.: 45,301

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JUN-19-2006(MON) 15:22 MANNAVA &amp; KANG, P. C.

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P. O. Box 272400  
Fort Collins, Colorado 80527-2400RECEIVED  
CENTRAL FAX CENTER

X)703 8655150

P. 002/012

PATENT APPLICATION

JUN 19 2006

ATTORNEY DOCKET NO. 10005208-1

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Osamu Samuel NAKAGAWA

Confirmation No.: 3642

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Title: HIGH-DIELECTRIC CONSTANT METAL-INSULATOR METAL CAPACITOR IN VLSI  
MULTI-LEVEL METALLIZATION SYSTEMSMail Stop Amendment  
Commissioner For Patents  
PO Box 1450  
Alexandria, VA 22313-1450TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment ( ) Petition to extend time to respond  
 ( ) New fee as calculated below ( ) Supplemental Declaration  
 (X) No additional fee  
 ( ) Other: \_\_\_\_\_ (fee \$ \_\_\_\_\_)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	12	MINUS	20	= 0	X \$50	\$ 0
INDEP. CLAIMS	2	MINUS	3	= 0	X \$200	\$ 0
[ ] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$360	\$ 0
EXTENSION FEE	1ST MONTH \$120.00	2ND MONTH \$450.00	3RD MONTH \$1020.00	4TH MONTH \$1590.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Osamu Samuel NAKAGAWA

By

Ashok K. Mannava

Attorney/Agent for Applicant(s)

Reg. No. 45,301

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Typed Name: Judy H. Chung

Signature: 

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Fort Collins, Colorado 80527-2400

MANNAVA & KANG, P. C.

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PATENT APPLICATION

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P. 003/012

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UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Osamu Samuel NAKAGAWA

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Examiner: Chuong A. Luu

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Mail Stop Amendment  
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Respectfully submitted,

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Number of pages: 12

Typed Name: Judy H. Chung

Signature: Judy H. Chung

Osamu Samuel NAKAGAWA

By Ashok K. Mannava

Ashok K. Mannava

Attorney/Agent for Applicant(s)  
Reg. No. 45,301

Date: June 19, 2006

HEWLETT-PACKARD COMPANY  
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Commissioner for Patents  
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Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated March 17, 2006, please amend the application  
as follows.